



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 3900  
Norio KIMURA et al. : Attorney Docket No. 2003\_1482  
Serial No. 10/694,047 : Group Art Unit 3724  
Filed October 28, 2003 : **Mail Stop: Issue Fee**

POLISHING METHOD AND APPARATUS  
(Rule 1.53(b) Divisional  
of Serial No. 09/545,504,  
Filed )

THE COMMISSIONER IS AUTHORIZED  
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CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-101125, filed April 8 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application of record in parent application Serial No. 09/545,504, filed April 7, 2000, now Patent No. 6,667,238.

Respectfully submitted,

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